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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/653,157
Filing Date August 31, 2000
Inventor Torek et al.
Assignee Micron Technology, Inc.
Group Art Unit 1765
Examiner Deo
Attorney's Docket No. MI22-1376
Title: Methods of Removing at Least Some of a Material from a Semiconductor Substrate

RESPONSE TO OCTOBER 22, 2002 OFFICE ACTION

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS

In the Claims

None.



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